**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

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| | Pan et al. | Docket No.: | TI-31192 |
| Serial No.: | 09/998,606 | Examiner: | Nguyen, C. |
| Filed: | 11/30/01 | Art Unit: | 2811 |
| Customer No.: | 23494 | Conf. No.: | 4902 |

For: HIGH DENSITY CAPACITOR USING TOPOGRAPHIC SURFACE

**REPLY UNDER 37 CFR 1.111**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The following remarks are offered in response to the Examiner's Office Action dated November 3, 2008. They are respectfully submitted as a full and complete response to that Action.

## REMARKS

Reconsideration of the above-referenced application in view of the following remarks is respectfully requested.

Claims 18-22 are pending in this case.

The Examiner rejected claims 18-20 under 35 U.S.C.§ 103(a) as being unpatentable over Vaartstra (U.S. Patent 6,010,969) in view of Ouellet et al.(U.S. Patent 6,268,620) and further in view of Yu et al. (U.S. Patent 6,211,008).